

TWENTY-FOURTH ANNUAL



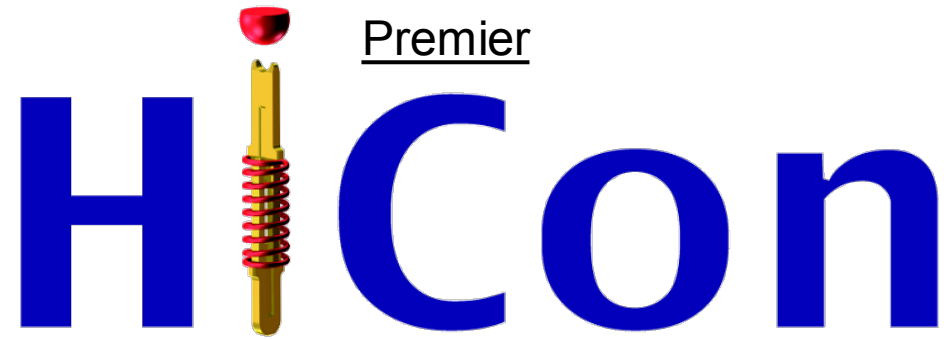
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March 5-8, 2023

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Thermal and Mechanical Challenges for Test Handlers

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Cohu, Inc



Mesa, Arizona • March 5-8, 2023



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Content

- Industry direction
- Different device types
- Device test flow
- Device tests
- Parallelism
- Device handling
- Temperature control
- Vision system
- MEMS



Thermal and Mechanical Challenges for Test Handlers

2 **2023**

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Industry Direction

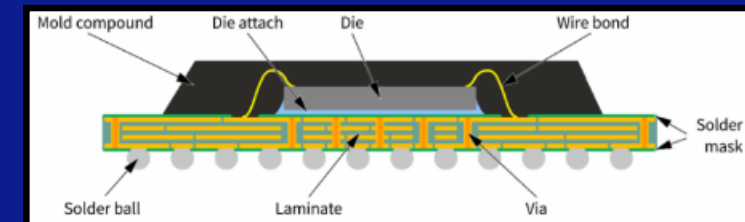
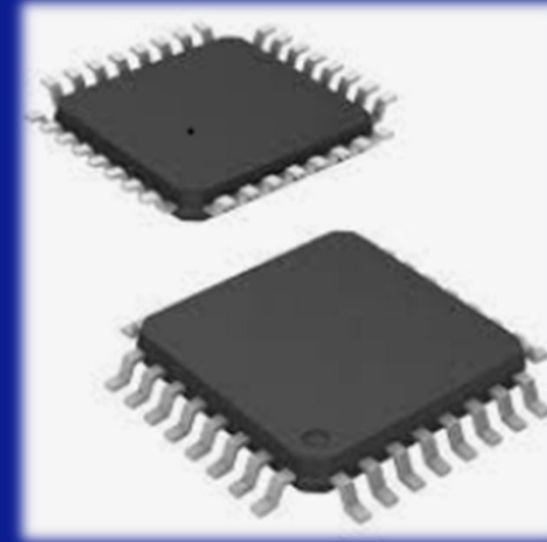
- 2 trends:
 - Devices shrinking
 - Integrated into more / new applications
 - Devices size increasing
 - Greater power levels



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Different device types (Smaller devices)

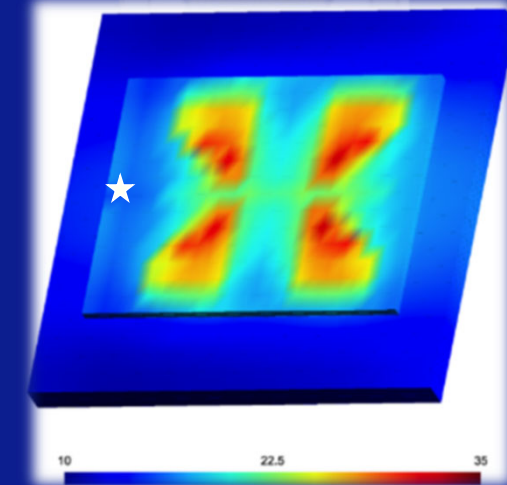
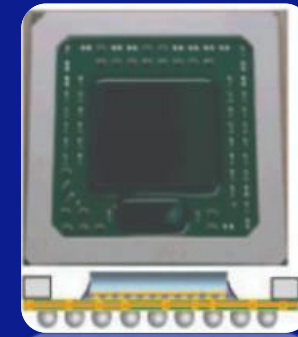
- Typical types: Over-molded & lidded
 - QFN, QFP & BGA
- Challenges:
 - Plastic over-mold thermally insulates die
 - Inverted thermal resistance (lower R_{jb} vs R_{jc})
 - Shrinking devices < 2mm x 2mm
 - Pick & place vs thermal fighting for limited area
 - Mechanical alignments
 - Smooth handling a must!
 - Fragile leads on some devices (QFP shown)



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Different device types (Large devices)

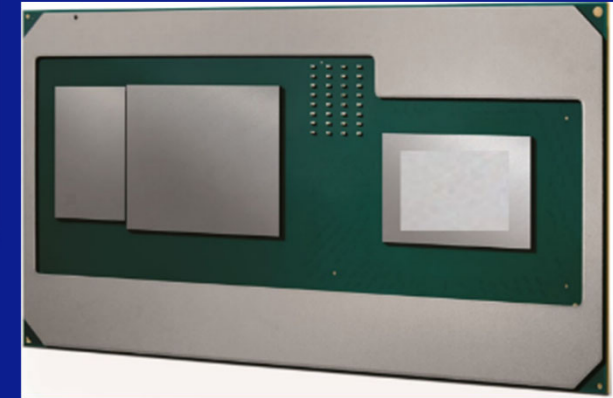
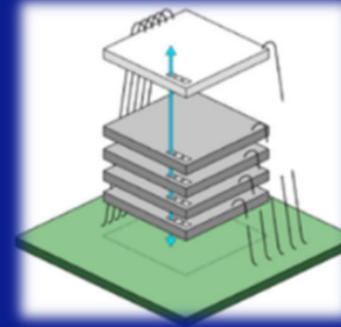
- Typical types: Lidded & Bare die
 - BGA, LGA
- Challenges:
 - Bare die cracking from hard contact
 - Deep socket designs
 - Both (above) require interposer hurting thermal performance
 - Temp feedback sensor far from high power die zones
 - Marring / residue on die or lid



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Different device types (Larger devices)

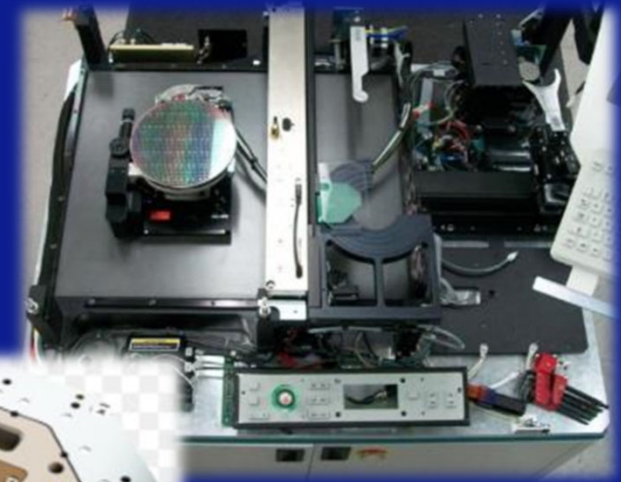
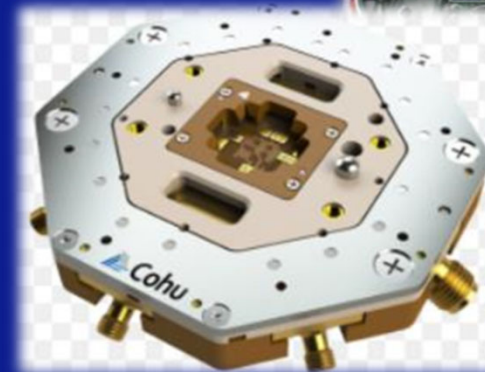
- Typical types: Multi chip modules
 - BGA, LGA
- Challenges:
 - Devices $> 100\text{mm} \times 100\text{mm}$
 - Size & weight exceeding handler's capabilities
 - Power dissipation $> 1000\text{W}$
 - Die stacking increases thermal resistance
 - Higher insertion forces driving thick stiffeners
 - Hide the die require interposer
 - Planarity between die affecting thermal contact



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Device test flow

- Wafer: Test ICs on the Si
- Functional: Test device performance
- Burn in: Test for infant mortality
- System level: Test device in real world use context



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Device tests (Temperature effects)

- Higher temperature results in lower reliability

$$A_T = e^{\frac{E_a}{k} \left(\frac{1}{T_{use}} - \frac{1}{T_{test}} \right)} \quad \text{Arrhenius equation}$$

- » E_a is the activation energy (from reference table)
- » k is Boltzmann's constant (8.617×10^{-5} eV/K)
- » T_{use} is the DUT junction temperature at application use
- » T_{test} is the DUT junction temperature in test

– Failure rate typically doubles every 15°C

- Circuits typically slow down with temperature
- Leakage current increases with temperature
 - ⇒ More power dissipation



8 **2023**

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Device tests (Voltage Acceleration)

- Voltage acceleration is given by:

$$A_V = e^{\beta(V_{test} - V_u)}$$

- Where:

V_u and V_{test} are use and test (stress) voltages, in volts
 β is the voltage acceleration term (4 per volt is typical)

- Goal is to maximize V_{test} without damaging the DUT
- Leakage current increases with voltage
⇒ More power dissipation



9 **2023**

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Device tests (Leakage current effects)

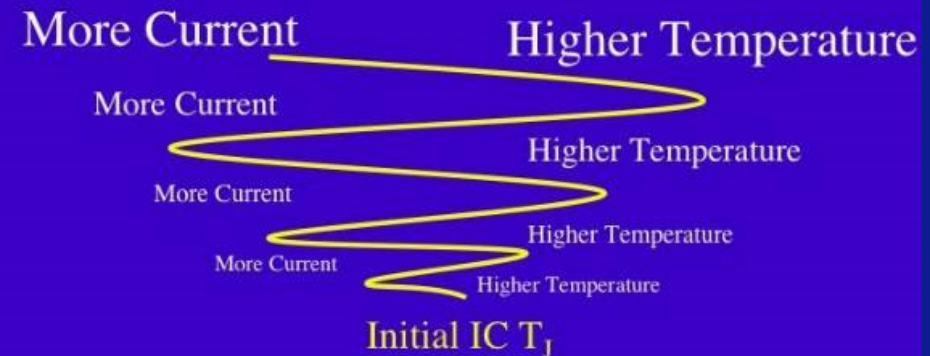
- Test stresses DUTs with voltage and temperature
 - Voltage and/or temperature increase will increase leakage current

$$I_{leak} = \mu_0 C_{OX} \frac{W}{L} e^{b(V_{dd} - V_{dd0})} V_T^2 \left(1 - e^{\frac{-V_{dd}}{V_T}}\right) e^{\frac{-|V_{th}| - V_{off}}{nV_T}}$$

- \Rightarrow More power dissipation

THERMAL RUNAWAY

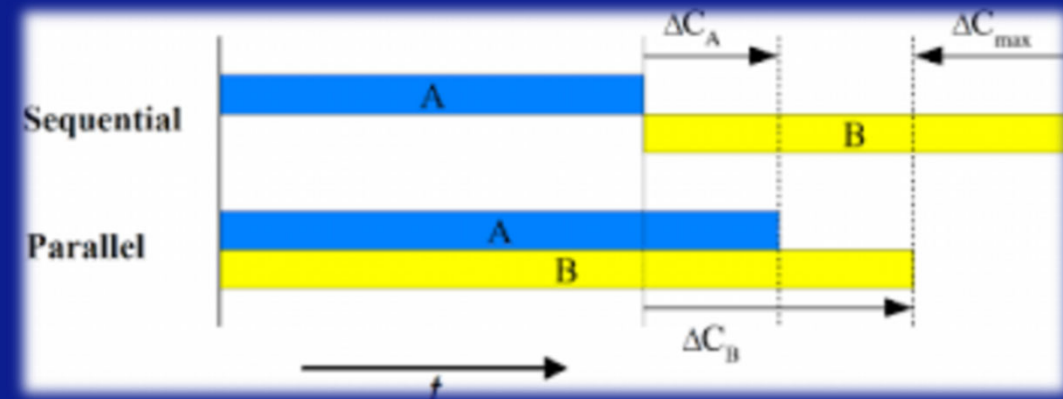
- Thermal runaway is a positive feedback phenomena in which leakage current and temperature interact in an exponential fashion with each other



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Parallelism (in test)

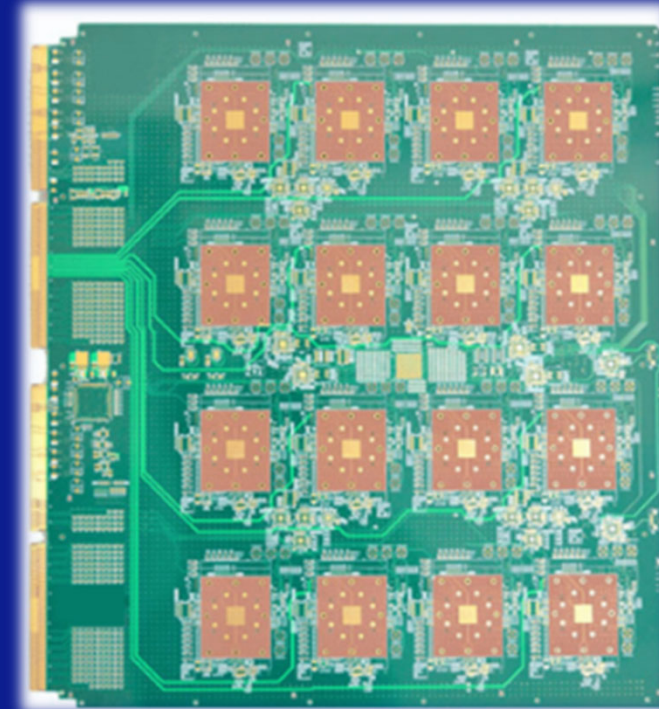
- Test time expensive on test floor
 - Target less test time per device
 - Maximize UPH (Units Per Hour)
- Push to run programs in parallel for test
 - \Rightarrow increases device power



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Parallelism (Mechanical)

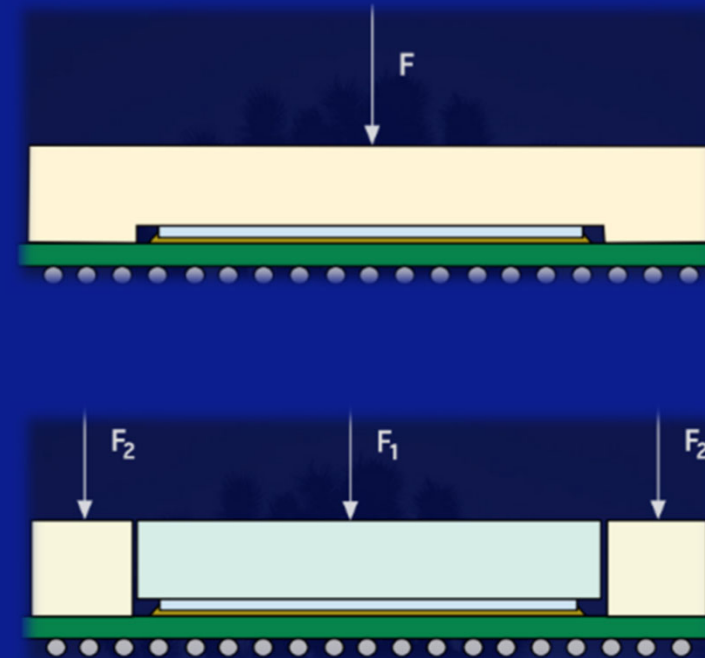
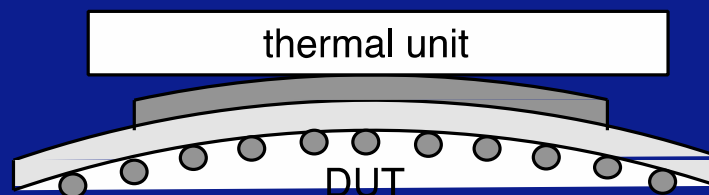
- \Rightarrow x64 and possibly higher
 - Maximize UPH (Units Per Hour)
- Power supply and cooling magnitude impractical
- Handler doesn't grow proportionally
 - Pitch is reduced
- Scaling of mechanism complexity
- Higher socket insertion force



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Device handling (Forces)

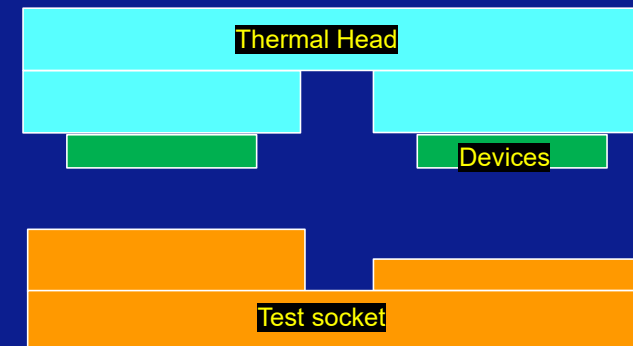
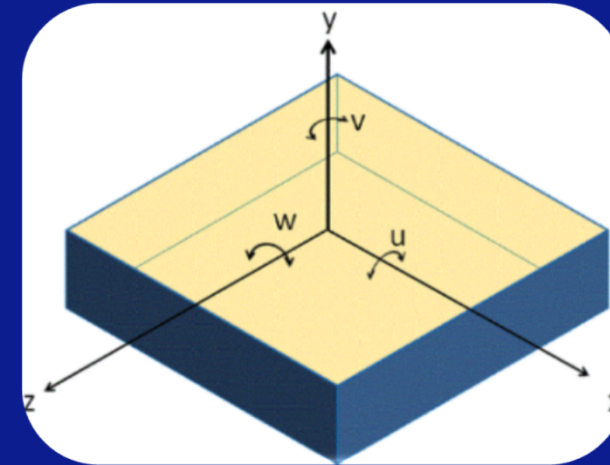
- Devices are not flat
- Devices can be bent with uneven loading
- Uniform applied force key to proper insertion
 - Socket and die force



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Device handling (Gimbaling and compliance)

- Accurately controlling device's 6 DOF is critical
 - Each device requires independent control
- Gimbal to make device coplanar & aligned with socket
- Compliance to account for tolerance stack up



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Device handling (Thermal considerations)

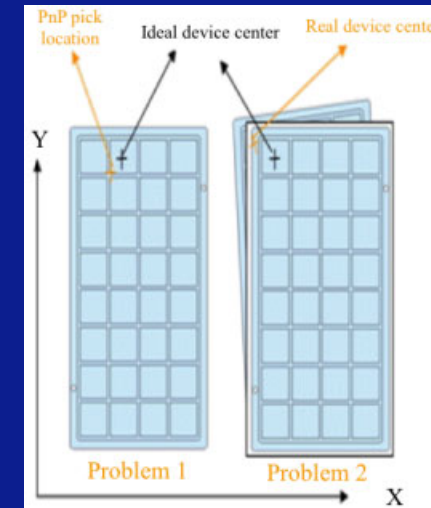
- Thermal expansion misaligns components
- Multiple test temperatures
 - Re-alignment not practical
- Proper soak temps critical to test time
 - Direct effect on UPH



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Device handling (IO alignments)

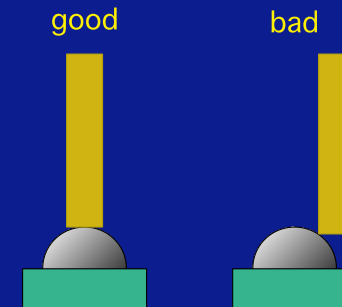
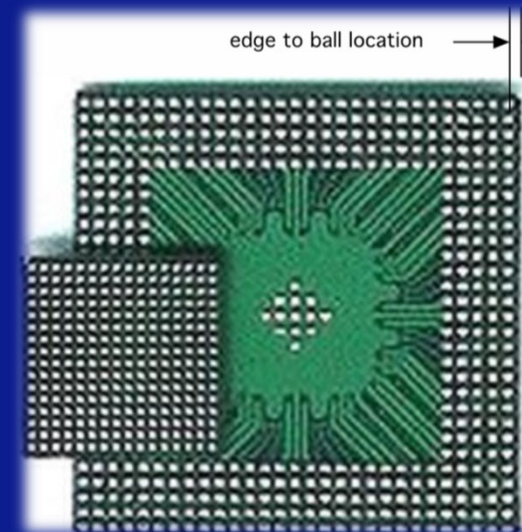
- Device transfer customer tray to handler
- Sub assembly tolerances must combine to small values
 - Tolerance stack up
- High speed moves > 1m distances
- Accelerations > 2 g's



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Device handling (Contactor alignment)

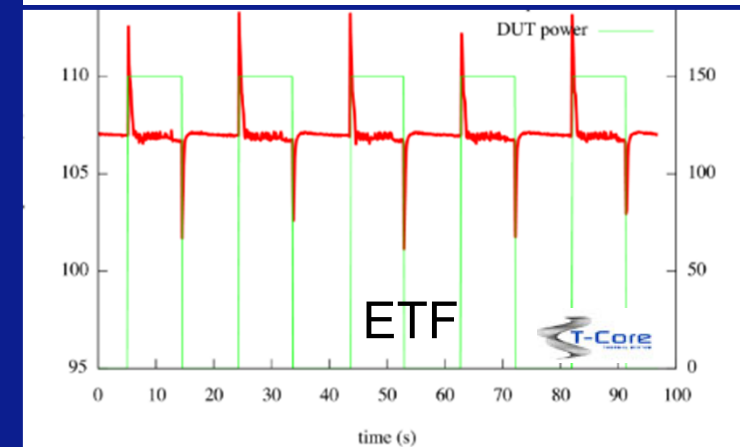
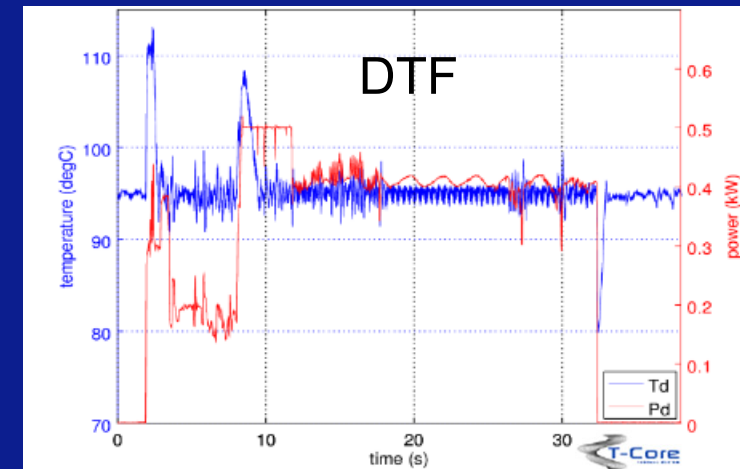
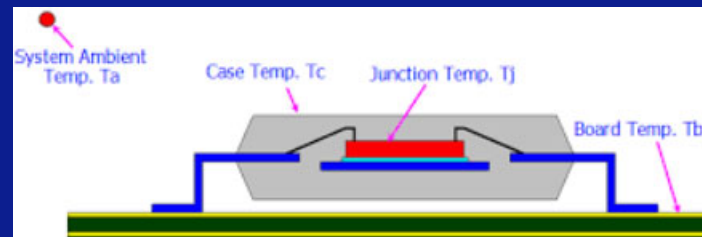
- 0.4mm pitch common
 - Tighter pitch coming
- Tolerances:
 - Device to edge tolerance
 - Other package tolerance
 - Thermal expansion
 - Cu lead frame 17 ppm/°C
 - Molding compound 10 – 25 ppm/ °C
 - 100°C temperature change
 - 25mm x 25mm package, 17 ppm/ °C
 - → 0.04mm expansion (non-correctable)
 - Socket/contactor expansion must be considered



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Temperature control (Control mode)

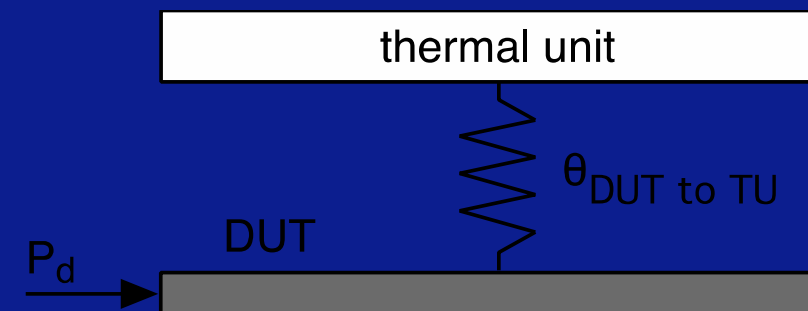
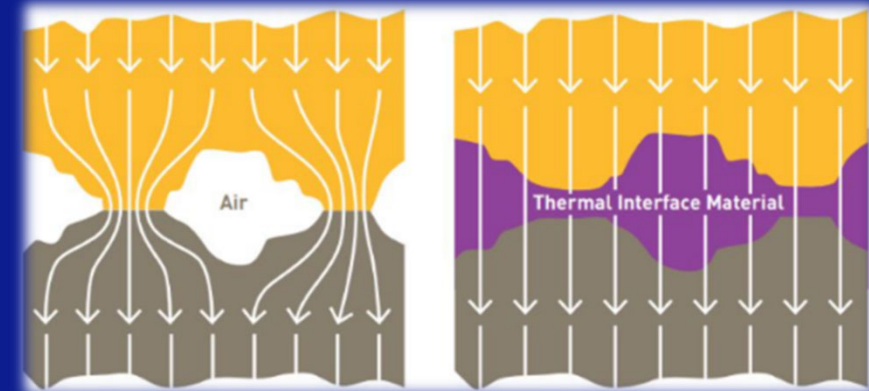
- Ideal test controls junction temp (T_j)
- Control system only as good as it's feedback
 - T_j feedback: DTF
 - Device power feedback: PF
 - No internal device feedback: ETF & HTF



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Temperature control (Thermal resistance)

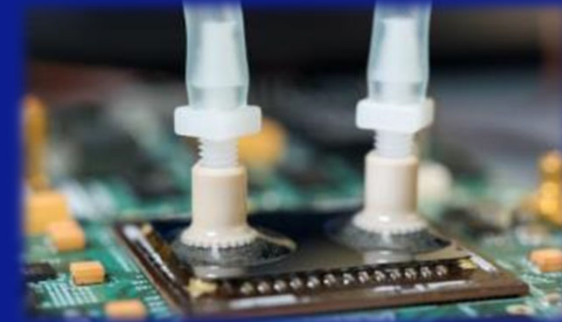
- 2 knobs for increased power dissipation
 - Lower thermal resistances
 - Interfaces
 - Device construction
 - Lower coolant temperature
 - Hot test best for power dissipation



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Temperature control (Cooling mediums)

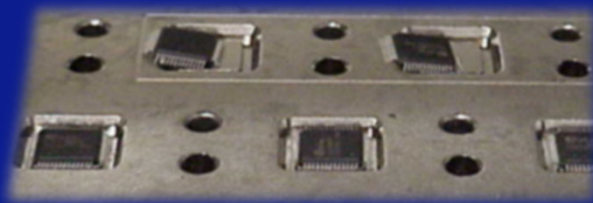
- Many options with different pros and cons
 - Customer preference/capabilities vary
 - Options: Air, water, HFE, LN2 & refrigerant
- Changing cooling mediums impractical in the field
 - Leads to over-engineered solutions



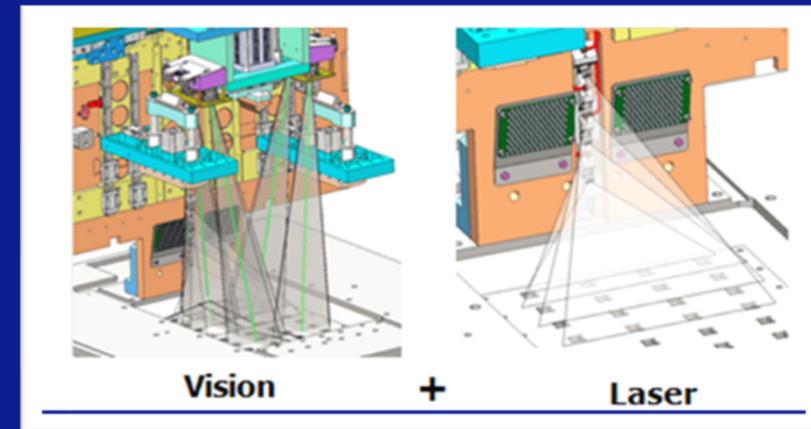
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Vision System (Process control)

- Out of pocket detection
 - Prevent damaging parts during pick and place
- Damaged devices
- Dropped devices
- Stuck devices
- etc.



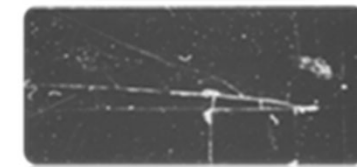
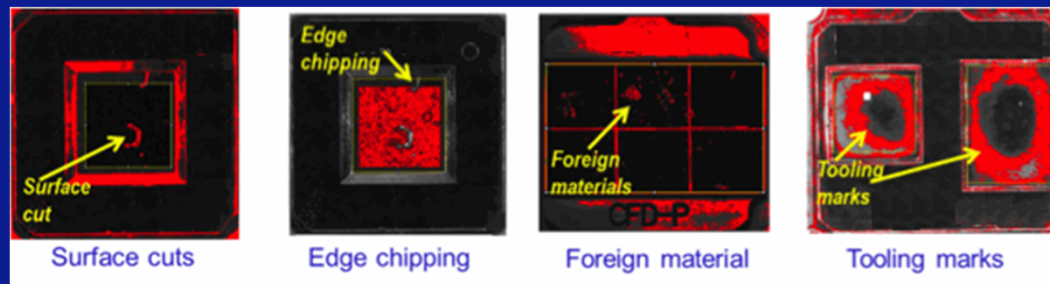
Device out of pocket



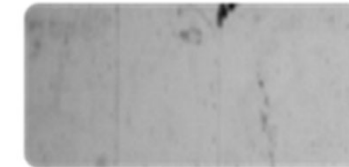
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Vision System (Quality control)

- Look for device defects
 - Compare incoming to outgoing devices (handler induced?)
- Inspect chuck
 - Examine surface contacting device for contamination
 - Heater on thermal chuck
 - Pedestal (part of heater)



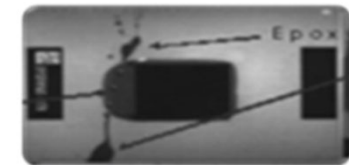
Cracks



Edge chips



Stains

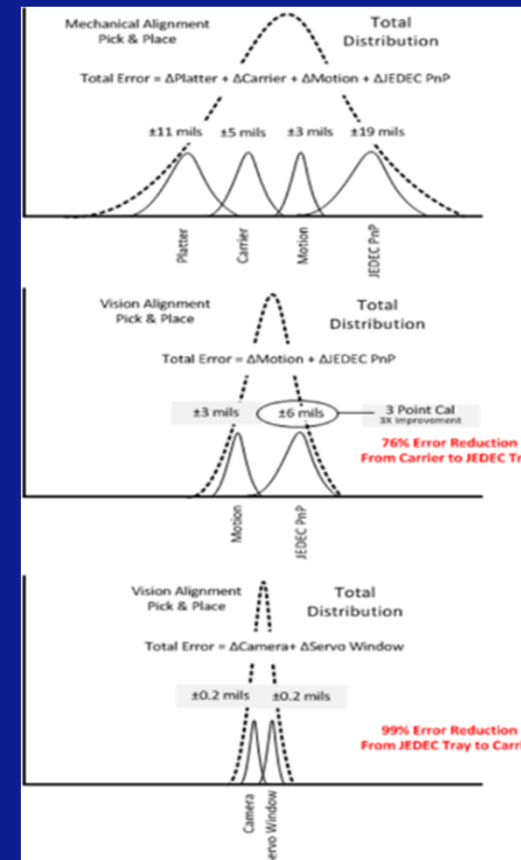


FM Contamination

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Vision Systems (Alignment)

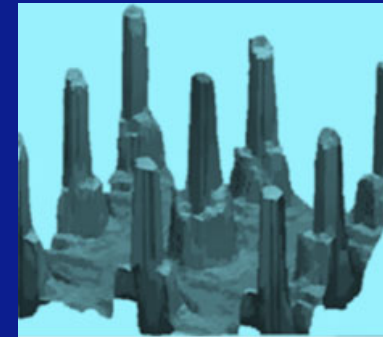
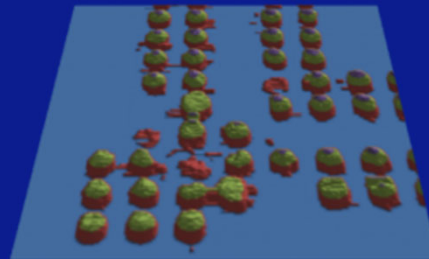
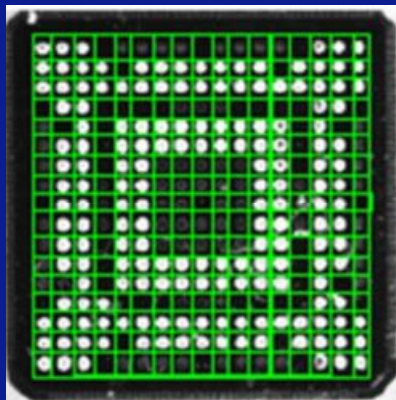
- Tool calibration reduces ~75% of alignment errors
- In situ alignment eliminates ~99% of errors
- Based on device IO matrix (solder balls, etc) corrections in X, Y, and θ



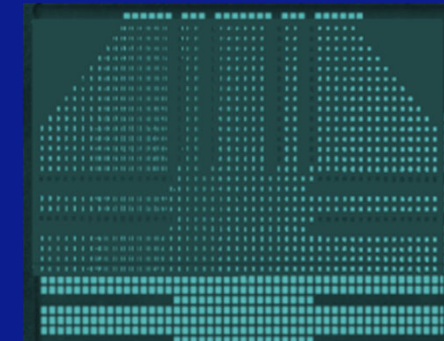
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Vision system (Bottom side defects)

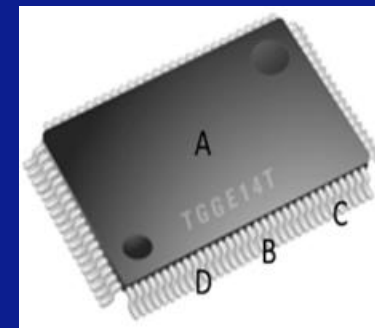
- BGA:
 - Damaged balls
 - Missing balls
 - Extra balls
 - Solder debris



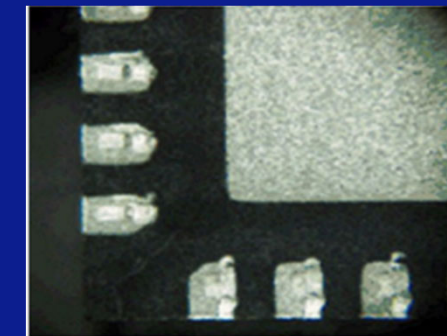
PGA – bent pin



LGA - contamination



QFP – bent lead

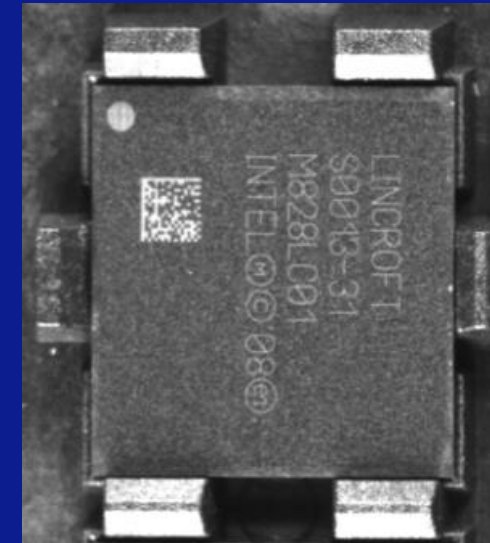
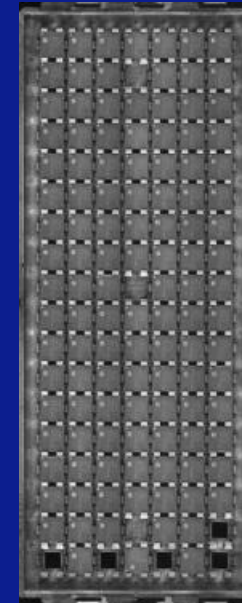
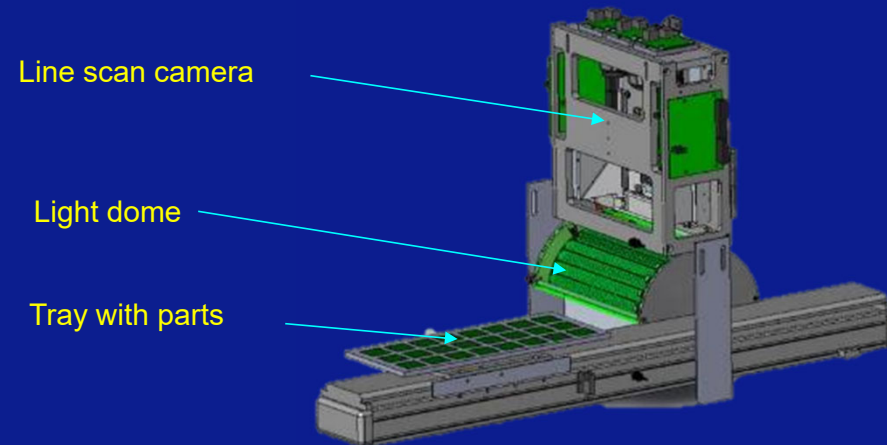


QFN – damaged pad

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Vision system (Tray level)

- Tray level line scans:
 - Empty pocket detection
 - 2DID for sort/binning
 - Part orientation using pin 1



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Microelectromechanical systems (MEMS)

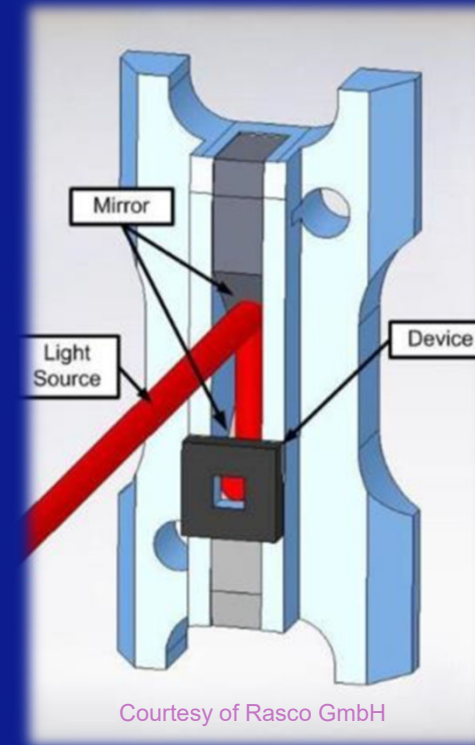
- Testing requires physical stimulus
- Cost of test up to 50% of device cost
- Market drivers:
 - Lower cost over time
 - Higher functionality (i.e., complexity) over time
- Stimulus mechanism temperature range (-55 °C to 160 °C)



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MEMS (Optical sensors)

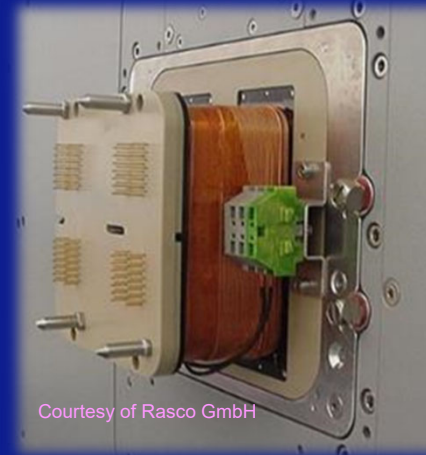
- Geometric accuracy
 - Positioning accuracy
 - Precision mirrors
- Intensity control
- Light source needs to be thermally isolated from temperature conditioned device



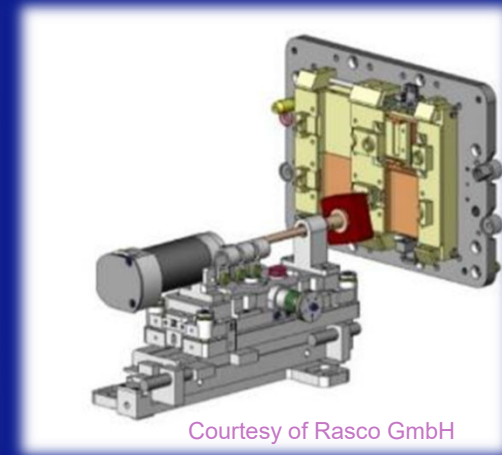
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MEMS (Hall sensors)

- Measurement of magnetic flux density
- Moving a device into magnetic field of a coil
 - Change magnetic field intensity
- Moving a device into magnetic field of a permanent magnet
 - Change orientation of magnetic field (rotate magnet)



Courtesy of Rasco GmbH

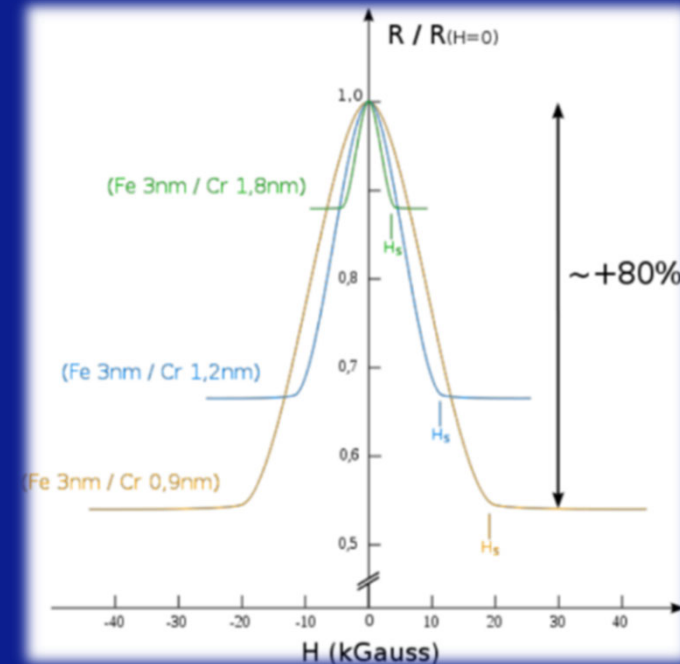


Courtesy of Rasco GmbH

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MEMS (GMR)

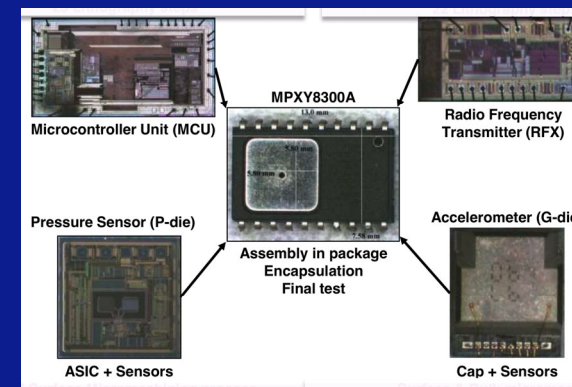
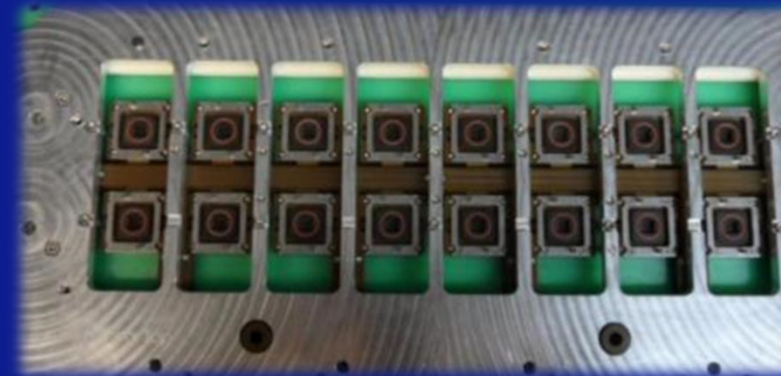
- GMR – giant magnetoresistance
- Resistance dependent on magnetic field
- For test
 - Change of the magnetic field in the contactor
 - Measurement of magnetic field intensity



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MEMS (Pressure transducers)

- From millibars (absolute) to 10 bar
 - Vacuum/pressure in single test
- Multiple pressure levels
 - Minimum stabilization time
- Live or dead bug access
- Seal to device
- Minimal air consumption
- High accuracy to set point
- Temperature/humidity control
- Low noise
- Radio RFX transmission (tire sensor)



tire sensor

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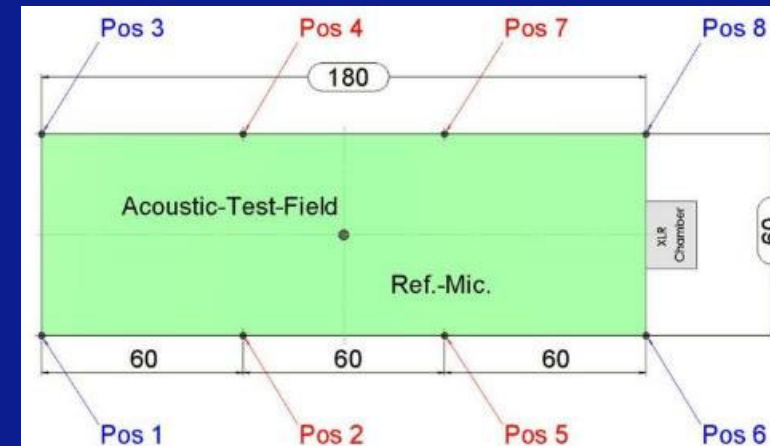
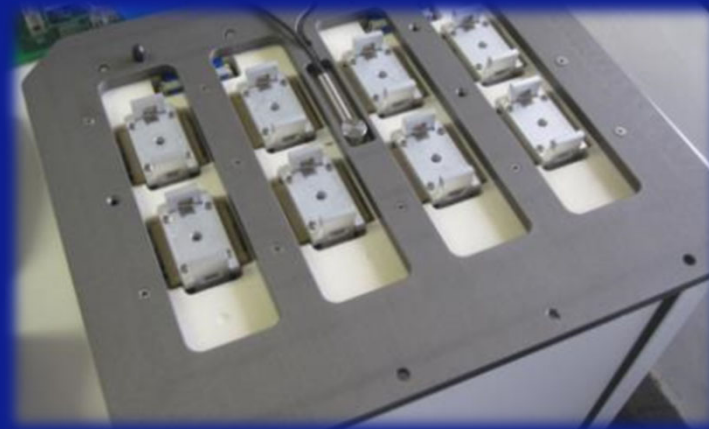
MEMS (Acoustic sensors)

- Frequency response
 - 50Hz. to 20kHz.
 - 100Hz. \leftrightarrow 3.4m wavelength
- Sound pressure level
- Sensitivity
- Distortion
- Signal to noise ratio
- Isolation from ambient noise (handler!)
- Live and dead bug configurations



MEMS (Acoustic sensors)

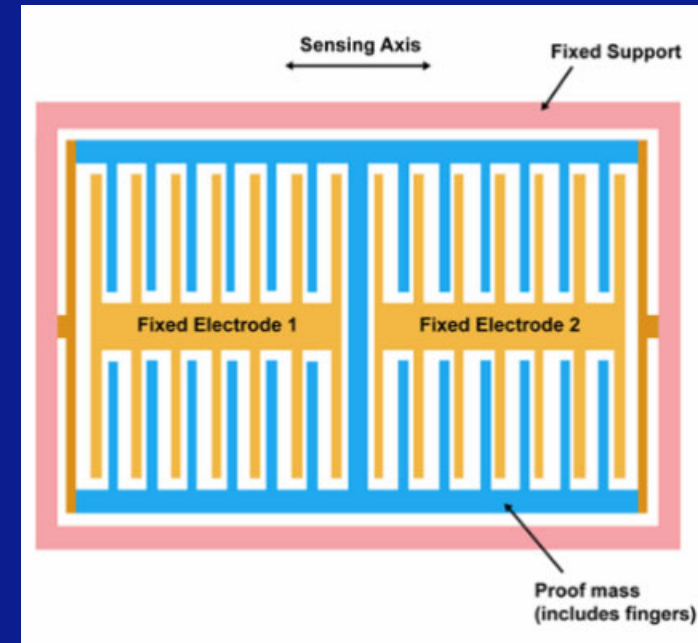
- Stimulus uniformity over parallel test sites



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MEMS (Low g/gyro)

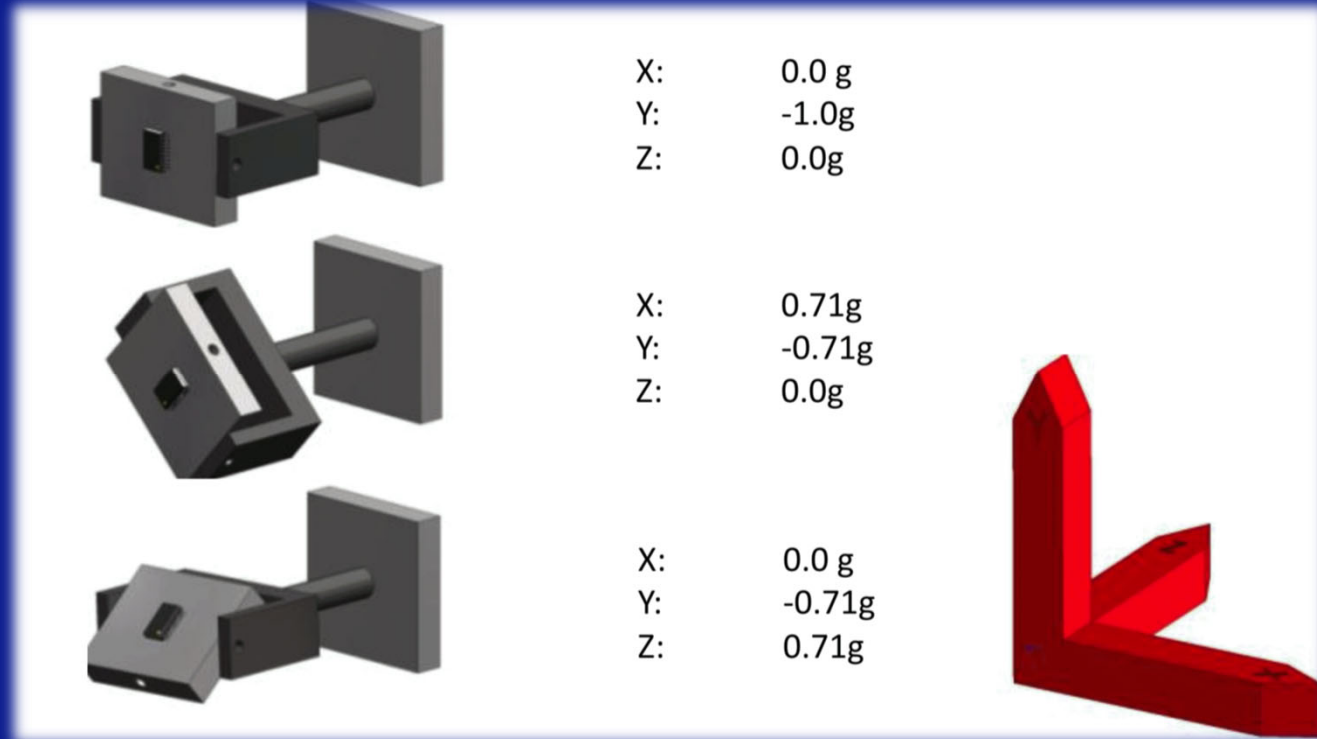
- **Static test**
 - Measure low g by aligning to gravity
 - Can measure multiple axes
 - *Any strain exerted on device can affect output!*
- **Dynamic test**
 - Values of $g > 1$
 - Gyro performance
- **Connectivity to devices complex**
- **BIST available but requires more device area (higher cost)**
 - Tradeoff: cost of test vs. extra area



<https://www.siliconsensing.com/technology/mems-accelerometers/>

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MEMS (Low g/gyro – static test)



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MEMS (Multifunction)

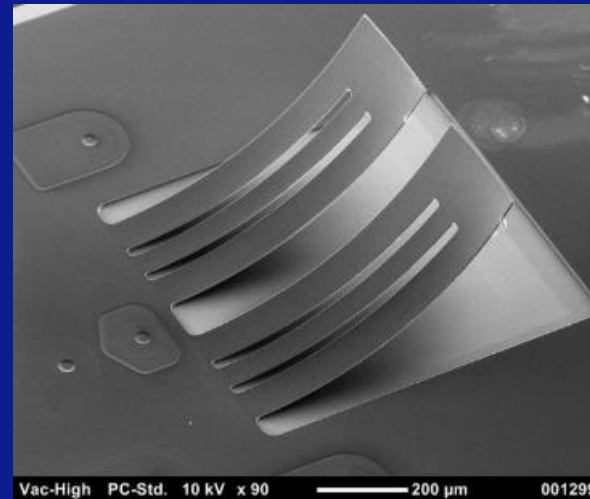
- Inertial measurement units (IMUs)
 - Tri-axis, digital accelerometer
 - Tri-axis, digital gyroscope
 - Tri-axis, digital magnetometer
 - Digital pressure sensor



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MEMS (Viscosity sensor)

- Bio-sensor, measures blood viscosity
- Not practical to test with fluids!



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Conclusion

- Devices will continue to get more difficult to test
- Must continue to innovate and keep up with technology
- Must avoid being the bottleneck to progress!!

